



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 2, 2026

IGI Report Number

LG815606112

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

Measurements

7.11 X 5.10 X 3.38 MM

GRADING RESULTS

Carat Weight

1.06 CARAT

Color Grade

D

Clarity Grade

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

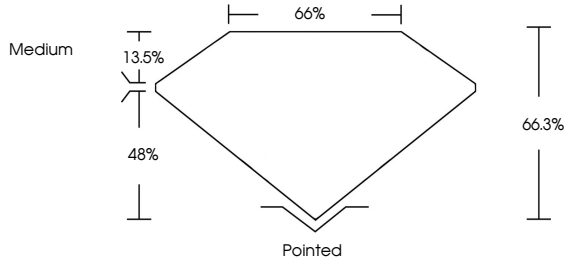
NONE

Inscription(s)

 LG815606112

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS





Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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July 2, 2026

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CUT CORNERED RECT. MODIFIED BRILLIANT

7.11 X 5.10 X 3.38 MM

Carat Weight

1.06 CARAT

Color Grade

D

Clarity Grade

VVS 1

Depth

66.3%

Table

65%

Girdle

Medium

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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